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PATENT  
Atty. Docket: 82821

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Nakamura et al.

Serial No.: 09/856,212

Filed: May 18, 2002

For: **PRODUCTION METHOD FOR SILICON  
SINGLE CRYSTAL WAFER**

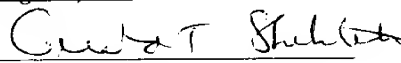
Examiner: Matthew J. Song

) Art Unit: 1765

) Confirmation No.: 9409

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} Gerald T. Shekleton Reg. No. 27,466

**AMENDMENT**

Mail Stop NON-FEE AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Office Action of May 6, 2003 has been carefully reviewed and the following amendments and remarks are made in response thereto.